

Notice of References Cited	Application/Control No. 10/579,389		Applicant(s)/Patent Under Reexamination SUZUKI ET AL.	
	Examiner Darcy D. LaClair		Art Unit 1796	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0147660	07-2004	Ishida et al.	524/442
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	WO 03010091 A1	02-2003	World Intellect	ENOKI H et al.	C08K 3/34
	O					
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	R					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Lenntech (1998) Silicon (Si) and Water: Reaction Mechanisms Online at: http://www.lenntech.com/periodic/water/silicon/silicon-and-water.htm
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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